課題番号 :F-20-IT-0007

利用形態 :機器利用

利用課題名(日本語) :液中分散非球形粒子の分離用マイクロ流路デバイスの開発

Program Title(English) : Separation of non-spherical particles using a microfluidic device

利用者名(日本語) :季広沖 ¹⁾, <u>西迫貴志 ²⁾</u>
Username(English) :G. Ji ¹⁾, <u>T. Nisisako ²⁾</u>

所属名(日本語) :1) 東京工業大学工学院,2) 東京工業大学科学技術創成研究院

Affiliation(English) :1) School of Engineering, Tokyo Institute of Technology

2) Institute of Innovative Research, Tokyo Institute of Technology

キーワード/Keyword:リソグラフィ・露光・描画装置、マイクロ流路デバイス、粒子分離

1. 概要(Summary)

We fabricated molds of negative photoresist SU8 to replicate polydimethylsiloxane (PDMS) micropillar devices using the facilities in Tokyo Institute of Technology. Effect of dose on the fabrication of SU-8 mold was evaluated.

2. 実験(Experimental)

【利用した主な装置】

電子ビーム露光データ加工ソフトウェア

マスクレス露光装置

【実験方法】

The data of the designed micropillar device was transformed for reading of maskless exposure system. The diameter of the pillars was set at 10 μ m. The size of gaps between the adjacent pillars was set at 6 μ m (Fig. 1)

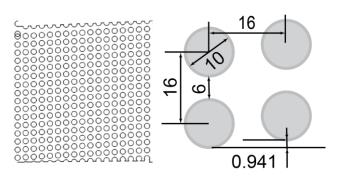


Fig. 1 Schematic illustration of the micropillars.

Next, the negative photoresist SU8-3025 was coated on a silicon wafer and was exposed to UV light. Then, the SU8-3025 was coated on the substrate once again (thickness: 7 μ m) and was processed by the maskless exposure system with

different doses (340 or 350 mJ/cm²). After exposure, the substrate was baked at 95°C for 5 min and developed for 5 min.

3. 結果と考察(Results and Discussion)

The three SU-8 molds were observed using an optical microscope equipped with a camera (Fig. 2). The gap sizes under two different doses were 3.4 μ m (340 mJ/cm², Fig. 2a), 3.6 μ m (340 mJ/cm², Fig. 2b) and 4.7 μ m (350 mJ/cm², Fig. 2c), respectively. As the dose increased, the gap size decreased. Therefore, to fabricate a device with gap size of 6 μ m, the optimal dose is expected to be higher than 350 mJ/cm². This would be examined further in the future.

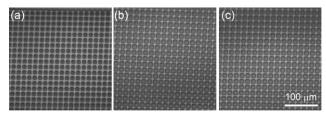


Fig. 2 Three SU8 3025 micro patterns processed with two different doses. (a)340 mJ/cm², (b) 340 mJ/cm².

4. その他・特記事項(Others)

・技術支援者の河田様,守田様に感謝致します。

5. 論文・学会発表 (Publication/Presentation) なし。

6. 関連特許(Patent)

なし。